

17-0497-200&210

CONSTRUCTION ANALYSIS ON ADA4177-2 MANUFACTURED BY ANALOG DEVICES AT TO AND AFTER REFLOW

Report performed for:

SCHLUMBERGER

26, RUE DE LA CAVÉE BP 202 92140 CLAMART FRANCE

Analysis performed in a laboratory with a Quality Management System certified AFAQ ISO 9001



VAVITARIS OBTECLIAE:

Eight ADA4177-2 from ANALOG DEVICES were submitted to SERMA Technologies laboratory for a construction analysis at T0 and after reflow.

PRODUCT REFERENCES:

♦ Reference: ADA4177-2

Package type: 8-Lead SOIC

Manufacturer: Analog devices

iaikiigs.

bHILIPINES Bottom:

<u>Top:</u> 4177-2 4699 9969

VCEING:

- Three parts supplied at TO.
- Double reflow simulations on five parts: Lead free profile (temperature peak = 260° C)

KESULTS AND INTERPRETATIONS:

- Before and after reflow, delaminations were observed at lead/resin interfaces in bonding areas during the acoustic inspection of the parts.
- After chemical opening, no assembly defect was observed; internal connections as well as die attach processes were correctly mastered.
 The wiring was performed by 25 µm diameter gold wires; wire pull results were satisfactory.
- Wo anomaly was observed on die surface during optical inspections.

Approved by: JM. ETCHARREN
Project Manager

Performed by: J. JOURDAN



ANALYSIS FLOW

The analysis was performed on the components following this procedure

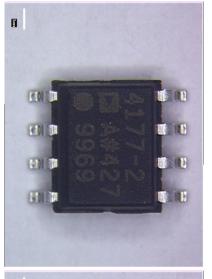
	T0 (3 parts)	After reflow (5 parts)
EXTERNAL VISUAL INSPECTION	3 parts	NP
X-RAYS INSPECTION (2 AXES)	3 parts	NP
WIRE BALL BOND CROSSECTION	1 part	NP
OPTICAL AND SEM INSPECTIONS OF SECTIONS	1 part	NP
WETTABILITY	2 parts	NP
T0 ACOUSTIC MICROSCOPY	1 part	NP
BAKING 24H AT 125°C	NP	All parts
DOUBLE SIMULATION REFLOW PROFIL SAC	NP	All parts
ACOUSTIC MICROSCOPY AFTER REFLOW	NP	1 part
CHEMICAL OPENING AFTER REFLOW	NP	5 parts
OPTICAL AND SEM INSPECTIONS OF OPENED PARTS	NP	1 part
WIRE PULL TEST 40 WIRES	NP	5 parts

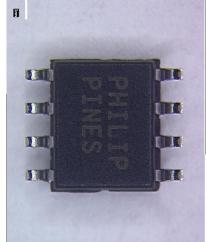
NP: Not Performed

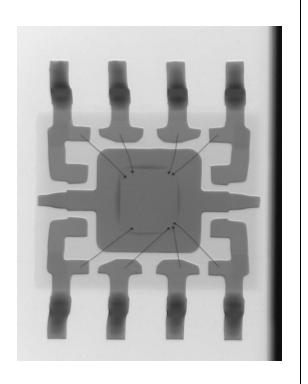


INITIAL (0H) CONTROL Manuf. Reference ADA4177-2 ANALOG DEVICES Package Wire **Date Code** SOIC-8 8

External Visual Inspection







Radiography Inspection (Top and Side)



COMMENTS: None.

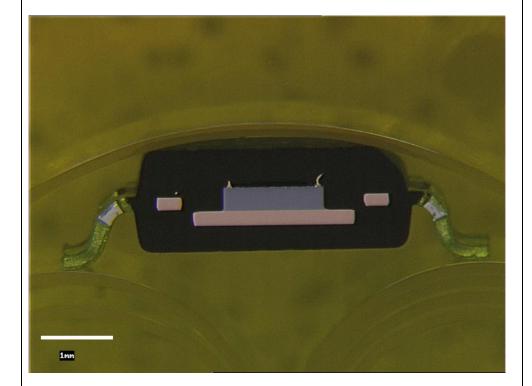


INITIAL (0H)
CROSS-SECTION

Reference Manuf.

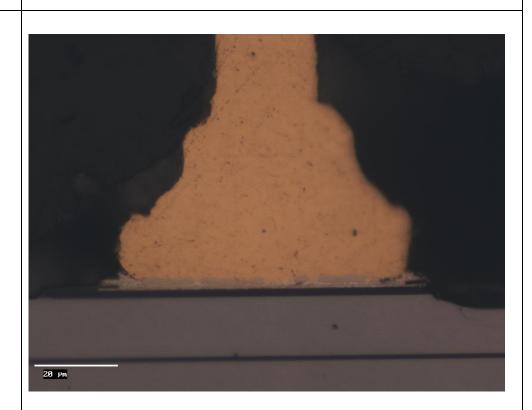
ADA4177-2 ANALOG DEVICES Package SOIC-8 Wire 8 Date Code -

Cross-section Inspection



Cross section inspection

Optical general view of the section plane



Cross section inspection

Optical view of the ball bond



INITIAL (0H) CROSS-SECTION	Reference Manuf.	ADA4177-2 ANALOG DEVICES	Package SOIC-8 Wire 8 Date Code -
		Cross-section Ins	•
SEM inspection SEM view of the ball bond		Mag = 1.20 K X 10 µm* EHT = 20.00 kV	WD = 15.2 mm Signal A = BSD
SEM inspection SEM view of ball / pad interface		Mag = 1.50 K X 10 µm* EHT = 20.00 kV	
SEM inspection SEM detailed view of the Au / Al interface Au/Al intermetallics ≈1.5µm		AuAl interme	

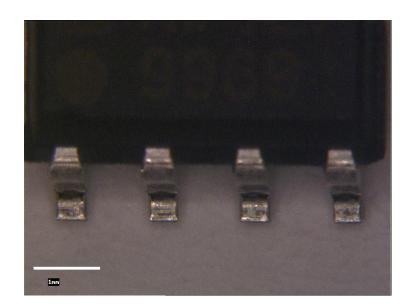
Package SOIC-8 Wire 8 Date Code - ction	WD = 15.2 mm Signal A = BSD	WD = 15.2 mm Signal A = BSD
ADA4177-2 ANALOG DEVICES DEVICES DEVICES D Cross-section Inspection	X 100 Lm* EHT = 20.00 KV	KX 10 µm* EHT = 20.00 kV
Reference ON	iew bly Mag = 110 ×	ection If the die
INITIAL (0H) CROSS-SECTION	Cross section inspection Optical general view of the die assembly	Cross section inspection Optical detailed view of the die attach



INITIAL (0H) CROSS-SECTION	Reference Manuf.	ADA4177-2 ANALOG DEVICES	Package Wire Date Code	SOIC-8 8 -
		Wettability test		

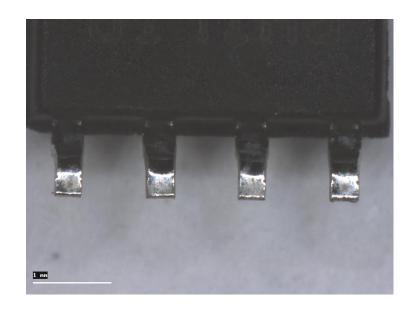
Part inspection

Before wettability test



Part inspection

After wettability test



COMMENTS:

- Before test: No abnormal aspect or coloration was observed.
- After test, visual inspection of leads revealed no unwetting, no dewetting area or pinholes. The height of solder fillet was greater than the immersion depth.



Before/after reflow and after ACOUSTIC MICROSCOPY cycling

Reference Manuf.

ADA4177-2 ANALOG DEVICES

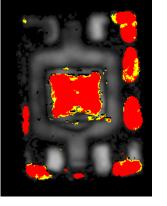
Package Wire **Date Code**

SOIC-8 8

ACOUSTIC MICROSCOPY INSPECTION (TOP view)

T0 (after reflow)

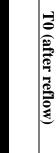
 $\mathbf{0}$



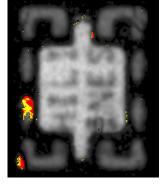
T0 (after reflow) Die coat	T0 Die coat	Top Die	
0	0	Perimeter (%)	
Exit	0	Tie bar (%)	Lead frame
No	No	Entire length Die to package exit, I.A.	me
Yes	Yes	Bonding area	
100	100	Delamination (% max)	Lead
Yes	Yes	Entire length to package exit	
ı	1	Other (crack, void)	

ACOUSTIC MICROSCOPY INSPECTION (BOTTOM view)

 $\mathbf{T0}$







		Lead frame	me	Lead	ad	
Bottom	Surface	Tie bar (%)	Entire length to package exit	Delamination (% max)	Entire length to package exit	Other (crack, void)
T0	0	0	1	0	-	I
T0 (after reflow)	0	0	-	60	No	ı

COMMENTS:

Delaminations were observed at lead/package resin interfaces in bonding areas before and after



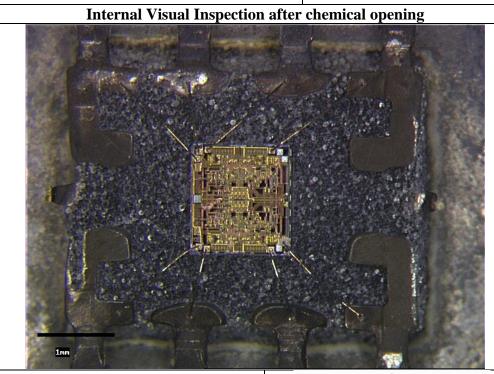
INITIAL (0H) OPENING &
WIRE PULL TEST

Reference Manuf.

ADA4177-2 ANALOG DEVICES Package SOIC-8 Wire 8 Date Code -

Opened Quantity 5 parts

Bonding Material Au Wire diameter 25 µm

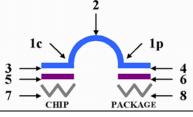


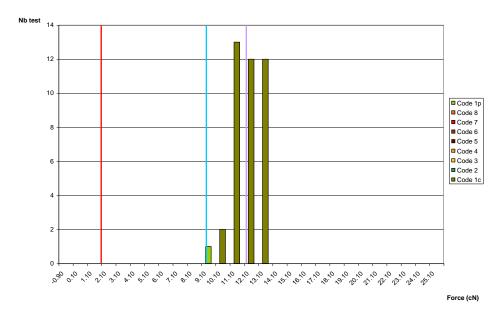
Breaking codes:

Number of no rupture :

•		
CODE 1c Number test CODE 1c :	39	
CODE 1p Number test CODE 1p:	1	
CODE 2 Number test CODE 2:	0	
CODE 3 Number test CODE 3:	0	
Number test CODE 4 :	0	
CODE 5 Number test CODE 5:	0	
CODE 6 Number test CODE 6:	0	
CODE 7 Number test CODE 7:	0	
CODE 8 Number test CODE 8:	0	
Total number of tests :	40	

Breaking codes





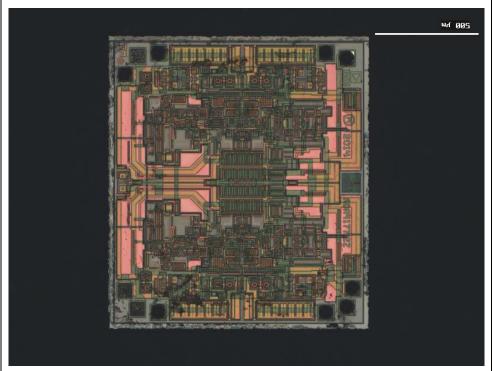
COMMENTS

Usual rupture codes (1c and/or 2 and/or 1p). **Acceptable** according to the standard.



Report 17-0497-200&210 March 15th 2017 Page 10 / 12

gr	inəqo lsəimədə	ternal Visual Inspection after	aI	
- 8 2OIC-8	Package Wire Date Code	PAPTOG DEAICES PDV4177-2	Reference Manuf.	INILIVT (0H) OBENING
Ch 15" 2017				



Optical inspection

Optical general view of die





Optical inspection

Optical detailed views of markings

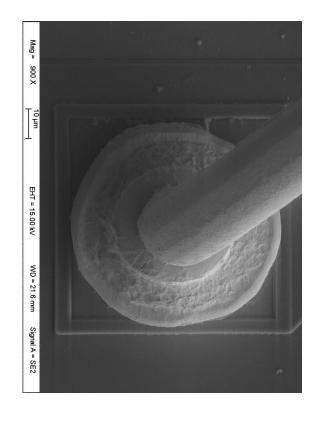


INITIAL (0H) OPENING	Reference ADA4177-2 Manuf. ANALOG DEVICES Internal Visual Inspection after of	Package SOIC-8 Wire 8 Date Code - chemical opening
SEM inspection SEM view of wire loop	Mag = 60 X 100 µm EHT = 15.00 kV	WD = 19.1 mm Signal A = SE2
SEM inspection SEM view of ball bond	Mag = 950 X 10 μm EHT = 15.00 kV	WD = 39.7 mm Signal A = SE2
SEM inspection SEM view of stitch bond	Mag = 900 X 10 µm EHT = 15.00 KV	WD = 18.0 mm Signal A = SE2

	INITIAL (0H) OPENING	
Internal Visual Inspection after chemica	Reference ADA4177-2 Manuf. ANALOG DEVICES	
nemical opening	Package SOIC-8 Wire 8 Date Code -	

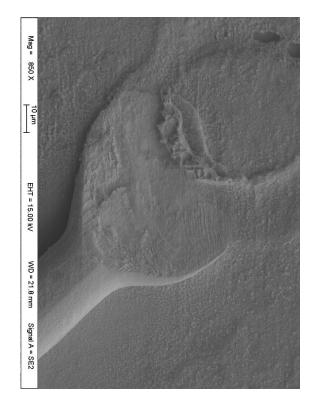
SEM inspection

SEM view of ball bond centering



SEM inspection

SEM view of stitch bond centering





Serma Technologies est un organisme indépendant dont le système qualité satisfait aux

A ce titre, un certain nombre d'informations générales relatives aux conditions exigences des normes ISO 9001.

expérimentales des analyses / essais et au contenu des rapports doit être mentionné.

ot əsnamrofnos ni zətarəqo həihw noitazinagro tnəbnəqəbni na zi zəigolonhəəT amrəl

For this purpose, general information related to experimental conditions of analyses/ requirements specified in the standards ISO 9001.

experiments and to content of the report have to be mentioned.

KELOKL / OBJECLS SUBMILTED TO ANALYSIS EVAPORT D'ESSAI - OBJETS SOUMIS A ESSAI /

It is important to notice that the report concerns only the objects submitted to analysis. Il est important de noter que le rapport ne concerne que les objets soumis à l'essai.

KEPRODUCTION / REPRODUCTION

ETECLKONIC WICKOSCOLK (SEW)

WEZURE

Ce rapport ne doit pas être reproduit partiellement sans l'approbation écrite du laboratoire

d'essai.

This report cannot be partially reproduced without the laboratory written authorisation.

VCCNKVCX SLVLEWENL INCERTITUDE DE MESURE /

 $\overline{Electrical}$: Electrical values, except in specific cases which would be mentioned, are only given as an et ne sont utilisées que pour mettre en évidence le bon ou le mauvais fonctionnement d'un composant. Electriques: Les grandeurs électriques, sauf indications contraires, ne sont données qu'à titre indicatif

photographies qui peuvent ou non figurer dans ce rapport. En tenant compte de toutes les incertitudes Dimensionnelles: Les données dimensionnelles présentées dans ce rapport ont été relevées sur des indication of the good or wrong functioning of a component.

Aguovat bənimvətəb nəəd əvad sizylana zidt ni bətvoqəv atab lanoiznəmib ədT: Innoiznəmi \overline{d} avons estimé les valeurs ci-dessous: de mesures (révélations chimiques, imprécisions de mesure, étalonnage de nos équipements ...), nous

(chemical revelation, measure imprecision, equipment calibration...), we have provided value photographs, which may or may not appear in this report. Given all the measure inaccuracy

: wol9d 9ldbt 9ht ni znoitsmite9

$\%$ $\subsetneq \mp$	MICKOSCOPIE ELECTRONIQUE (MEB)
%	Oblical Microscopy Microscopie Optique
VCCNBVCX SLYLEWENL	WEVZNBEWENL

titre indicatif seulement. Les mesures des profondeurs de jonction, ainsi que les valeurs inférieures à 0,2 µm, sont données à

% S∓

INCERTITUDE

The junction depth measurements as well as values less than 2.0 µm are given only as an indication.